| L Number       | Hits | Search Text   | DB                     | Time stamp        |
|----------------|------|---|------------------------|-------------------|
| 1              | 714  | (347/20).CCLS.  | USPAT;                 | 2004/02/18 12:49  |
|                |      |   | US-PGPUB;              |                   |
|                |      |   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                | ,    |   | IBM_TDB                | 0004/00/10 10 10  |
| 2              | 648  | (347/29).CCLS.  | USPAT;                 | 2004/02/18 12:49  |
|                |      |   | US-PGPUB;<br>EPO; JPO; |                   |
|                |      |   | DERWENT;               |                   |
|                |      |   | IBM TDB                |                   |
| 3              | 760  | (347/40) CCLS.  | USPAT;                 | 2004/02/18 12:49  |
|                | , 55 | ,   | US-PGPUB;              |                   |
| '              |      |   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                |      | (247/44) 0010   | IBM_TDB                | 2004/02/10 10:50  |
| 4              | 512  | (347/44).CCLS.  | USPAT;<br>US-PGPUB;    | 2004/02/18 12:50  |
| į i            | =    |   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                |      |   | IBM TDB                |                   |
| 5              | 1302 | (347/47).CCLS.  | USPAT;                 | 2004/02/18 12:50  |
|                | . ,  |   | US-PGPUB;              |                   |
|                | ,    |   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                |      | (0.45 (5.4), 0.67 5   | IBM_TDB                | 0004/00/100 15 5: |
| 6              | 715  | (347/54).CCLS.  | USPAT;                 | 2004/02/18 12:51  |
| .              |      |   | US-PGPUB;<br>EPO; JPO; |                   |
|                |      | •   | DERWENT;               |                   |
|                |      |   | IBM TDB                |                   |
| 7              | 67   | (((347/20).CCLS.) or ((347/29).CCLS.) or  | USPAT;                 | 2004/02/18 12:54  |
|                |      | ((347/40).CCLS.) or ((347/44).CCLS.) or   | US-PGPUB;              |                   |
| į į            |      | ((347/47).CCLS.) or ((347/54).CCLS.)) and   | EPO; JPO;              |                   |
|                |      | (silicon adj nitride) and ((oxidiz\$3 or  | DERWENT;               |                   |
|                |      | oxide) with (passage\$1 or channel\$1 or  | IBM_TDB                |                   |
|                | 225  | hole\$1 or nozzle\$1 or through\$1hole\$\$1))                                     | HCDAM.                 | 2004/02/10 16 22  |
| -              | 395  | (216/27).CCLS.  | USPAT;<br>US-PGPUB;    | 2004/02/10 16:30  |
|                |      | ·   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                |      |   | IBM TDB                | ,                 |
| -              | 172  | (438/21).CCLS.  | USPAT;                 | 2004/02/10 16:30  |
|                |      |   | US-PGPUB;              |                   |
|                |      |   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
| _              | C40  | /20/990 1) COLC   | IBM_TDB                | 2004/02/10 16-20  |
| <del>-</del> . | 649  | (29/890.1).CCLS.  | USPAT;<br>US-PGPUB;    | 2004/02/10 16:30  |
| İ              |      | ·   | EPO; JPO;              |                   |
|                |      | ·   | DERWENT;               |                   |
| . 1            |      |   | IBM TDB                |                   |
| -              | 1090 | ((216/27).CCLS.) or ((438/21).CCLS.) or   | USPĀT;                 | 2004/02/10 16:30  |
|                | 4    | ((29/890.1).CCLS.)  | US-PGPUB;              |                   |
|                |      | i   | EPO; JPO;              |                   |
|                |      |   | DERWENT;               |                   |
|                | 147  | (//216/27) COTC ) on ///20/21) COTC )   | IBM_TDB                | 2004/02/10 16-26  |
| _              | 143  | (((216/27).CCLS.) or ((438/21).CCLS.) or ((29/890.1).CCLS.)) and nozzle\$1 and    | USPĀT;<br>US-PGPUB;    | 2004/02/10 16:36  |
|                |      | ((29/890.1).CCLS.)) and nozzle\$1 and (silicon adj (nitride and \$20xide))        | EPO; JPO;              |                   |
|                |      | (SEEE ON GO) (MECHAGO GIA VEONIGE))   | DERWENT;               |                   |
|                |      | ·   | IBM TDB                |                   |
| -              | 138  | (((216/27).CCLS.) or ((438/21).CCLS.) or  | USPAT;                 | 2004/02/10 16:33  |
|                |      | ((29/890.1).CCLS.)) and nozzle\$1 and   | US-PGPUB;              |                   |
|                |      | (silicon adj (nitride and \$2oxide)) and  | EPO; JPO;              |                   |
| İ              |      | etch\$3   | DERWENT;               |                   |
|                | 4.0  |   | IBM TDB                | 2004/02/10 16 25  |
| _              | 40   | ((inkjet or ink-jet or (ink adj jet)) and   | USPAT;                 | 2004/02/10 16:37  |
|                |      | (nozzle\$1 or hole\$1 or opening\$1) and (silicon adj (nitride and \$20xide)) and | US-PGPUB;<br>EPO; JPO; |                   |
|                |      | etch\$3).clm.   | DERWENT;               |                   |
|                |      | 3201175/ OIM  | IBM TDB                |                   |
|                |      | L   |                        | 1                 |

| [  |                                       |
|--|---------------------------------------|
| - 42 ((inkjet or ink-jet or (ink adj jet)) and USPAT;  | 2004/02/10 16:37                      |
| (nozzle\$1 or hole\$1 or opening\$1 or US-PGPU   |                                       |
| channel\$1) and (silicon adj (nitride and   EPO; JE  | ?O;                                   |
| \$20xide)) and etch\$3).clm. DERWENT   | ?;                                    |
| IBM_TDE  |                                       |
| - 173 (((216/27).CCLS.) or ((438/21).CCLS.) or USPAT;  | 2004/02/10 16:37                      |
| ((29/890.1).CCLS.)) and (nozzle\$1 or US-PGPU  | ·                                     |
| hole\$1 or opening\$1 or channel\$1) and EPO; JE   | 1                                     |
| (silicon adj (nitride and \$20xide)) DERWENT   | 1                                     |
| IBM_TDE  | I I                                   |
| - 1371 (inkjet or ink-jet or (ink adj jet)) and USPAT;   | 2004/02/10 16:38                      |
| (nozzle\$1 or hole\$1 or opening\$1) and US-PGPU   |                                       |
| (silicon adj (nitride and \$20xide)) and EPO; JE   |                                       |
| etch\$3  | 1                                     |
| IBM_TDE   1027 (inkjet or ink-jet or (ink adj jet)) and USPAT;                                       | 2004/02/10 16:38                      |
| 1  |                                       |
| nozzle\$1 and (silicon adj (nitride and US-PGPU \$20xide))   |                                       |
| DERWENT  | · · · · · · · · · · · · · · · · · · · |
| IBM TOE  | - 1                                   |
| - 841 (inkjet or ink-jet or (ink adj jet)) and USPAT;  | 2004/02/18 10:33                      |
| nozzle\$1 and (silicon adj (nitride and US-PGPU  |                                       |
| \$20xide)) and etch\$3 EPO; JE   |                                       |
| DERWENT  |                                       |
| IBM TDE  | -                                     |
| - 148 (inkjet or ink-jet or (ink adj jet)) and USPAT;  | 2004/02/17 14:31                      |
| (nozzle\$1 with method).clm. and (silicon US-PGPU  | JB;                                   |
| adj (nitride and \$20xide)) and etch\$3 EPO; JE  |                                       |
| DERWENT  | Γ;                                    |
| IBM_TDE  |                                       |
| - 278 ((chamber or nozzle\$1) with ink).clm. and USPAT;  | 2004/02/17 14:31                      |
| (silicon adj (nitride and \$20xide)) and US-PGPU   | · 1                                   |
| mask\$3  | · · ·                                 |
| DERWENT  | . 1                                   |
| IBM_TDE<br> - 289 ((chamber or nozzle\$1 or passage) with USPAT;                                     | 2004/02/18 10:31                      |
| - 289 ((chamber or nozzle\$1 or passage) with USPAT; ink).clm. and (silicon adj (nitride and US-PGPU | 1                                     |
| \$20xide)) and mask\$3 EPO; JE   | · 1                                   |
| perwent  |                                       |
| IBM TOE  | · 1                                   |
| - 318 (inkjet or ink-jet or (ink adj jet)) and USPAT;  | 2004/02/17 18:34                      |
| nozzle\$1 and (silicon adj nitride) and US-PGPU  |                                       |
| oxidiz\$3 and etch\$3 EPO; JE  | · •                                   |
| DERWENT  | r;                                    |
| IBM_TDE  | 1                                     |
| - 297 ((chamber or nozzle\$1 or passage or hole USPAT;   | 2004/02/18 10:32                      |
| or (through adj hole)) with ink).clm. and US-PGPU  | ·                                     |
| (silicon adj (nitride and \$20xide)) and EPO; JE   |                                       |
| mask\$3  |                                       |
| IBM_TDE  |                                       |
| - 246 ((chamber or nozzle\$1 or passage or hole USPAT;   | 2004/02/18 10:36                      |
| or (through adj hole))).clm. and US-PGPU   | ·                                     |
| (printhead or inkjet or ink-jet or (ink EPO; JE adj jet)) and (silicon adj nitride) and DERWENT      |                                       |
| oxidiz\$3  |                                       |
| - 259 ((chamber or nozzle\$1 or passage or hole USPAT;   | 2004/02/18 10:37                      |
| or (through adj hole))).clm. and ((liquid US-PGPU  |                                       |
| adj jet) or (recording adj head) or EPO; JE  |                                       |
| printhead or inkjet or ink-jet or (ink adj   DERWENT   | 1                                     |
| jet)) and (silicon adj nitride) and IBM TDE  |                                       |
| oxidiz\$3  |                                       |

|   |      |   | T         | 0004/00/40 77    |
|---|------|---|-----------|------------------|
| - | 446  | (((chamber or nozzle\$1 or passage or hole  | USPAT;    | 2004/02/18 11:34 |
|   |      | or (through adj hole)) with ink).clm. and   | US-PGPUB; |                  |
|   |      | (silicon adj (nitride and \$20xide)) and  | EPO; JPO; |                  |
|   |      | mask\$3) or (((chamber or nozzle\$1 or  | DERWENT;  |                  |
|   |      | passage or hole or (through adj   | IBM_TDB   |                  |
|   |      | hole))).clm. and (printhead or inkjet or  |           |                  |
| . |      | ink-jet or (ink adj jet)) and (silicon adj  |           |                  |
|   |      | nitride) and oxidiz\$3 ) or ((chamber or  | ~         |                  |
|   | 1    | nozzle\$1 or passage or hole or (through  |           |                  |
|   |      | adj hole))).clm. and ((liquid adj jet) or<br>(recording adj head) or printhead or |           |                  |
| ] |      | inkjet or ink-jet or (ink adj jet)) and   |           |                  |
|   |      | (silicon adj nitride) and oxidiz\$3 )   |           |                  |
| _ | . 36 |   | USPAT;    | 2004/02/18 11:35 |
|   | . 50 | or (through adj hole)) with ink).clm. and   | US-PGPUB; | 2004/02/10 11:33 |
|   |      | (silicon adj (nitride and \$20xide)) and  | EPO; JPO; |                  |
|   |      | mask\$3) or (((chamber or nozzle\$1 or  | DERWENT;  |                  |
|   |      | passage or hole or (through adj   | IBM TDB   |                  |
|   |      | hole))).clm. and (printhead or inkjet or  | _         |                  |
|   |      | ink-jet or (ink adj jet)) and (silicon adj  |           | ·                |
|   |      | nitride) and oxidiz\$3 ) or (((chamber or   |           |                  |
|   |      | nozzle\$1 or passage or hole or (through  |           |                  |
|   |      | adj hole))).clm. and ((liquid adj jet) or   |           |                  |
|   |      | (recording adj head) or printhead or  |           |                  |
|   |      | inkjet or ink-jet or (ink adj jet)) and   |           |                  |
|   |      | (silicon adj nitride) and oxidiz\$3 )) and  |           |                  |
|   |      | (nozzle\$1 with protru\$5)  |           |                  |



Day: Wednesday Date: 2/18/2004 Time: 12:23:37

### **Inventor Name Search Result**

Your Search was:

Last Name = FUJITA First Name = HIROYUKI

|                 | *************************************** |        |            |  |                  |
|-----------------|---|--------|------------|--|------------------|
| Application#    | Patent#                                 | Status | Date Filed | Title  | Inventor Name 51 |
| 60441518        | Not<br>Issued                           | 020    | ·          | COIL ARRAYS FOR PARALLEL<br>IMAGING IN MAGNETIC RESONANCE<br>IMAGING   | FUJITA, HIROYUKI |
| 60341468        | Not<br>Issued                           | 159    |            | HEAD QUADRATURE COIL ARRAYS<br>FOR PARALLEL IMAGING IN<br>MAGNETIC RESONANCE IMAGING   | FUJITA, HIROYUKI |
| 60308455        | Not<br>Issued                           | 159    |            | MRI TRANSCEIVER COIL SYSTEM FOR<br>BREAST IMAGING  | FUJITA, HIROYUKI |
| 60302158        | Not<br>Issued                           | 159    | 06/29/2001 | HEAD COIL ARRAYS FOR PARALLEL<br>IMAGING IN MAGNETIC RESONANCE<br>IMAGING  | FUJITA, HIROYUKI |
| 60296885        | Not<br>Issued                           | 159    | 06/08/2001 | COIL ARRAYS FOR PARALLEL<br>IMAGING IN MAGNETIC RESONANCE<br>IMAGING   | FUJITA, HIROYUKI |
| 10442155        | Not<br>Issued                           | 041    | 05/21/2003 | GAS INTRODUCTION APPARATUS<br>AND GAS ANALYZYER  | FUJITA, HIROYUKI |
| 10412267        | Not<br>Issued                           | 030    | 04/14/2003 | METHOD OF MANUFACTURING AN OXYGEN SENSOR   | FUJITA, HIROYUKI |
| <u>10367408</u> | Not<br>Issued                           | 030    | 02/14/2003 | VIDEO PLAYBACK CONTROL<br>APPARATUS, CONTENT PLAYBACK<br>CONTROL APPARATUS, AND METHOD<br>OF SUPPLYING COMMERCIAL<br>INFORMATION | FUJITA, HIROYUKI |
| 10357710        | Not<br>Issued                           | 061    | 02/04/2003 | DISPLAY DEVICE   | FUJITA, HIROYUKI |
| 10357709        | Not<br>Issued                           | 061    | 02/04/2003 | DISPLAY DEVICE   | FUJITA, HIROYUKI |
| 10320997        | Not<br>Issued                           | 040    |            | HEAD RF QUADRATURE COIL ARRAY<br>FOR PARALLEL IMAGING  | FUJITA, HIROYUKI |
| 10303850        | Not<br>Issued                           | 019    | 11/26/2002 | MULTILAYER TYPE PRINTED-WIRING<br>BOARD AND METHOD OF<br>MEASURING IMPEDANCE OF<br>MULTILAYER TYPE PRINTED-WIRING<br>BOARD       | FUJITA, HIROYUKI |
| 10282009        | Not<br>Issued                           | 092    | 10/29/2002 | FRONT-COVER ASSEMBLY AND INFORMATION APPARATUS HAVING THE SAME   | FUJITA, HIROYUKI |
| 10233522        | 6639497                                 | 150    | 09/04/2002 | STATIONARY INDUCTION   | FUJITA, HIROYUKI |

| · ·      |               |     | <u> </u>   | APPARATUS  |                  |
|----------|---------------|-----|------------|--|------------------|
| 10225386 | Not<br>Issued | 041 | 08/21/2002 | DISPLAY CONTROL APPARATUS FOR<br>DISPLAYING GAIN SETTING VALUE<br>IN PREDETERMINED COLOR HUE                               | FUJITA, HIROYUKI |
| 10221151 | Not<br>Issued | 041 |            | MICRO-ACTUATOR AND METHOD OF MANUFACTURING THE ACTUATOR  | FUJITA, HIROYUKI |
| 10205794 | Not<br>Issued | 041 | 07/26/2002 | RADIO FREQUENCY BREAST COIL<br>SYSTEM  | FUJITA, HIROYUKI |
| 10189802 | Not<br>Issued | 071 |            | ENGINE OXYGEN CONCENTRATION SENSOR MOUNTING STRUCTURE  | FUJITA, HIROYUKI |
| 10187353 | Not<br>Issued | 041 |            | HEAD COIL ARRAYS FOR PARALLEL<br>IMAGING IN MAGNETIC RESONANCE<br>IMAGING  | FUJITA, HIROYUKI |
| 10164664 | Not<br>Issued | 041 | 06/07/2002 | COIL ARRAYS FOR PARALLEL<br>IMAGING IN MAGNETIC RESONANCE<br>IMAGING   | FUJITA, HIROYUKI |
| 10088685 | Not<br>Issued | 030 | 03/21/2002 | METHOD FOR FINE PATTERN<br>FORMATION   | FUJITA, HIROYUKI |
| 09978666 | 6584840       | 150 | 10/18/2001 | ANGULAR VELOCITY SENSOR  | FUJITA, HIROYUKI |
| 09973183 | 6643045       | 150 | 10/10/2001 | OPTICAL SCANNER  | FUJITA, HIROYUKI |
| 09926152 | Not<br>Issued | 095 | 09/13/2001 | MECHANICAL OPTICAL SWITCH AND METHOD FOR MANUFACTURING THE SAME  | FUJITA, HIROYUKI |
| 09793977 | 6512181       | 150 |            | MULTILAYER TYPE PRINTED-WIRING<br>BOARD AND METHOD OF<br>MEASURING IMPEDANCE OF<br>MULTILAYER TYPE PRINTED-WIRING<br>BOARD | FUJITA, HIROYUKI |
| 09791085 | 6576023       | 150 | 02/22/2001 | METHOD AND APPARATUS FOR<br>MANUFACTURING MICROSPHERES   | FUJITA, HIROYUKI |
| 09671591 | 6679982       | 150 | 09/28/2000 | OXYGEN SENSOR  | FUJITA, HIROYUKI |
| 09671406 | 6422126       | 150 | 09/27/2000 | POWER STEERING APPARATUS   | FUJITA, HIROYUKI |
| 09670257 | 6393962       | 150 | 09/26/2000 | POWER STEERING APPARATUS   | FUJITA, HIROYUKI |
| 09663709 | Not<br>Issued | 080 |            | ANGIOTENSIN CONVERTING ENZYME INHIBITOR  | FUJITA, HIROYUKI |
| 09649595 | 6469607       | 150 | 08/29/2000 | STATIONARY INDUCTION<br>APPARATUS  | FUJITA, HIROYUKI |
| 09638261 | 6462563       | 150 | 08/11/2000 | FINGERPRINT READING DEVICE AND METHOD THEREOF  | FUJITA, HIROYUKI |
| 09634660 | 6401551       | 150 | 08/07/2000 | FINGERPRINT READING DEVICE   | FUJITA, HIROYUKI |
| 09634243 | Not<br>Issued | 061 | 08/08/2000 | FINGERPRINT READING DEVICE AND METHOD THEREOF  | FUJITA, HIROYUKI |
|          |               | Γ   | 11         |  |                  |

| 09624179 | 6523352       | 150 | 07/24/2000 | PIPING SUPPORT OF GAS TURBINE STEAM COOLED COMBUSTOR  | FUJITA, HIROYUKI |
|----------|---------------|-----|------------|---|------------------|
| 09609185 | Not<br>Issued | 061 | 06/30/2000 | DISPLAY DEVICE  | FUJITA, HIROYUKI |
| 09609049 | 6516134       | 150 | 11         | DATA RECORDING/REPRODUCING<br>METHOD AND APPARATUS  | FUJITA, HIROYUKI |
| 09589232 | Not<br>Issued | 160 | 06/07/2000 | OPTICAL ADD-DROP MULTIPLEXER  | FUJITA, HIROYUKI |
| 09568713 | 6341278       | 150 | 05/11/2000 | RECORDING AND REPRODUCING APPARATUS AND METHOD FOR ACCESSING DATA STORED ON A RANDOMLY ACCESSIBLE RECORDING MEDIUM, AND FOR MANAGING DATA THEREON | FUJITA, HIROYUKI |
| 09562288 | 6494094       | 150 | 05/01/2000 | ANGULAR RATE SENSOR   | FUJITA, HIROYUKI |
| 09555892 | 6461337       | 150 | 07/28/2000 | ELECTROSTATIC MICROACTUATORS,<br>ACTIVE THREE-DIMENSIONAL<br>MICROCATHETERS USING SAME AND<br>METHOD FOR MAKING SAME                              | FUJITA, HIROYUKI |
| 09530063 | 6299911       | 150 | 04/24/2000 | EXTRACT OF TOUCH CONTAINING<br>AN ALPHA-GLUCOSIDASE INHIBITOR   | FUJITA, HIROYUKI |
| 09513062 | 6316941       | 150 | 02/24/2000 | OPEN VIEW QUADRATURE BIRDCAGE<br>COIL   | FUJITA, HIROYUKI |
| 09509899 | 6337372       | 150 | 04/03/2000 | PROPYLENE/PROPYLENE/OLEFIN BLOCK COPOLYMER AND PROCESS FOR PRODUCING THE SAME   | FUJITA, HIROYUKI |
| 09508799 | 6326432       | 150 | 03/17/2000 | POLYPROPYLENE COMPOSITION   | FUJITA, HIROYUKI |
| 09486921 | 6303698       | 150 | 05/09/2000 | PROPYLENE COPOLYMER AND<br>PROCESS FOR THE PRODUCTION<br>THEREOF  | FUJITA, HIROYUKI |
| 09485618 | 6365689       | 150 | 02/15/2000 | PROPYLENE/ETHYLENE RANDOM<br>COPOLYMER, MOLDING MATERIAL,<br>AND MOLDED ARTICLE   | FUJITA, HIROYUKI |
| 09485617 | 6441111       | 150 |            | POLYDISPERSE PROPYLENE POLYMER AND PROCESS FOR PRODUCING THE SAME   | FUJITA, HIROYUKI |
| 09485492 | 6410662       | 150 |            | PROCESS FOR THE PREPARATION OF<br>OLEFIN (CO)POLYMERS, OLEFIN<br>COPOLYMERS, AND APPLICATION<br>THEREOF   | FUJITA, HIROYUKI |
| 09467220 | 6498894       | 150 |            | VIDEO AND/OR AUDIO DATA<br>RECORDING AND/OR REPRODUCTION<br>APPARATUS   | FUJITA, HIROYUKI |
| 09341129 | 6225779       | 150 |            | A POWER SUPPLY MONITORING<br>INTEGRATED CIRCUIT DEVICE FOR<br>INDIVIDUALLY MONITORING   | FUJITA, HIROYUKI |

•

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### **Inventor Name Search Result**

Your Search was:

Last Name = MITA First Name = YOSHIO

| Application#    | Patent#       | Status | Date Filed | Title   | Inventor Name 8   |
|-----------------|---------------|--------|------------|---|-------------------|
| 10088685        | Not<br>Issued | 030    |            | METHOD FOR FINE PATTERN<br>FORMATION                            | MITA, YOSHIO      |
| 09763993        | 6520718       | 150    |            | SARDINE-BONE CONSTRUCTION<br>METHOD FOR LARGE-SECTION<br>TUNNEL | MITARASHI, YOSHIO |
| 09401947        | 6259548       | 150    | 09/23/1999 | A MICRO-MIRROR DEVICE   | MITA , YOSHIO     |
| <u>07678156</u> | 5156498       | 150    | 04/02/1991 | METHOD FOR CONTROLLING<br>MOISTURE CONTENT OF SILICA<br>POWDER  | MITANI , YOSHIO   |
| 07523664        | 5059087       | 150    | 05/15/1990 | BOBBIN CONVEYING SYSTEM   | MITANI , YOSHIO   |
| 06380812        | 4526502       | 150    |            | SLIDE FORK POSITIONING<br>APPARATUS                             | MITANI , YOSHIO   |
| 06380762        | Not<br>Issued | 161    | 05/21/1982 | CRANE POSITIONING APPARATUS                                     | MITANI , YOSHIO   |
| 06115727        | 4355581       | 150    | 01/28/1980 | TRUCK DRIVING APPARATUS   | MITANI , YOSHIO   |

Inventor Search Completed: No Records to Display.

| Coards Amadhan In  | Last Name | First Name |        |
|--------------------|-----------|------------|--------|
| Search Another: In | ventor    | yoshio     | Search |

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#### **Inventor Name Search Result**

Your Search was:

Last Name = OHIGASHI

First Name = RYOICHI

| Application# | Patent#       | Status | Date Filed | Title                                | Inventor Name 2    |
|--------------|---------------|--------|------------|--------------------------------------|--------------------|
| 10088685     | Not<br>Issued | 030    |            | METHOD FOR FINE PATTERN<br>FORMATION | OHIGASHI, RYOICHI  |
| 09394505     | 6089186       | 150    |            | VACUUM COATING FORMING<br>DEVICE     | OHIGASHI , RYOICHI |

Inventor Search Completed: No Records to Display.

| Search Another: Invento | Last Name | First Name |        |
|-------------------------|-----------|------------|--------|
| Search Another. Invento | ohigashi  | oichi      | Search |

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#### **Inventor Name Search Result**

Your Search was:

Last Name = TSUCHIYA First Name = KATSUNORI

| Application#    | Patent#       | Status | Date Filed | Title   | Inventor Name 10        |
|-----------------|---------------|--------|------------|---|-------------------------|
| 10455375        | Not<br>Issued | 030    | 06/06/2003 | PERMANENT RESIST, PERMANENT<br>RESIST-LAMINATED SUBSTRATE<br>AND PROCESS FOR PRODUCING THE<br>SAME                                      | TSUCHIYA, KATSUNOR      |
| 10088685        | Not<br>Issued | 030    | l l        | METHOD FOR FINE PATTERN<br>FORMATION  | TSUCHIYA, KATSUNOR      |
| 09472782        | 6280799       | 150    | 12/28/1999 | VISCOUS SUBSTANCE DISCHARGING METHOD USING A VISCOUS SUBSTANCE DISPENSER AND PATTERN FORMING METHOD USING A VISCOUS SUBSTANCE DISPENSER | TSUCHIYA, KATSUNOR      |
| 09407999        | 6575564       | 150    | 09/29/1999 | INK JET RECORDING METHOD USING HIGH VISCOUS SUBSTANCE AND APPARATUS FOR CARRYING OUT THE SAME   | TSUCHIYA ,<br>KATSUNORI |
| <u>09049056</u> | 6060215       | 150    | 03/27/1998 | PHOTOSENSITIVE RESIN COMPOSITION AND APPLICATION OF ITS PHOTOSENSITIVITY  | TSUCHIYA ,<br>KATSUNORI |
| 08460923        | Not<br>Issued | 161    | 06/05/1995 |   | TSUCHIYA ,<br>KATSUNORI |
| 08399219        | Not<br>Issued | 161    | 03/06/1995 | PHOTOSENSITIVE RESIN<br>COMPOSITION AND<br>PHOTOSENSITVE FILM USING THE<br>SAME   | TSUCHIYA ,<br>KATSUNORI |
| 08398809        | Not<br>Issued | 161    | 03/06/1995 | PHOTOSENSITIVE RESIN<br>COMPOSITION AND<br>PHOTOSENSITIVE FILM  | TSUCHIYA ,<br>KATSUNORI |
| 08361658        | Not<br>Issued |        | ·          | DEVELOPER FOR FORMING A PATTERN FROM A RADIATION SENSITIVE RESIN COMPOSITION  | TSUCHIYA ,<br>KATSUNORI |
| 07192785        | 4902726       | 150    |            | PHOTOSENSITIVE RESIN<br>COMPOSITION SOLUTION  | TSUCHIYA ,<br>KATSUNORI |

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